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In re Application of
Takahiro Oshita et al.
Application No. 09/180,601
Filed: November 10, 1998
Attorney Docket No. 01213/GEB667-US

ON PETITION

This is a decision on the petition under 37 CFR 1.137(b), filed June 18, 2001, to revive the above-identified application.

The petition is **GRANTED**.

The two-month period for filing an appeal brief in triplicate (accompanied by the fee required by 37 CFR 1.17(c)), runs from the date of this decision.

The above-identified application became abandoned for failure to reply within the meaning of 37 CFR 1.113 in a timely manner to the final Office action mailed November 29, 2000, which set a shortened statutory period for reply of three (3) months. Three (3) months extension of time under the provisions of 37 CFR 1.136(a) were obtained. Accordingly, the above-identified application became abandoned on May 30, 2001.

37 CFR 1.137(b)(3) requires a statement that the entire delay in filing the required reply from the due date for the reply until the filing of a grantable petition pursuant to 37 CFR 1.137(b) was unintentional. If the statement contained in the instant petition varies from the language required by 37 CFR 1.137(b)(3), the statement contained in the instant petition is being construed as the statement required by 37 CFR 1.137(b)(3) and petitioner must notify the Office if this is **not** a correct interpretation of the statement contained in the instant petition.

Telephone inquiries concerning this decision should be directed to Irvin Dingle at (703) 305-9282.

The application file is being forwarded to Technology Center 1700.

A handwritten signature in cursive script, appearing to read "Irvin Dingle".

Irvin Dingle

Petitions Examiner

Office of Petitions

Office of the Deputy Commissioner

for Patent Examination Policy